



ELECTRONIC COPY

LG655441737
Report verification at igi.org



September 30, 2024

IGI Report Number **LG655441737**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.87 X 5.57 X 3.83 MM**

GRADING RESULTS

Carat Weight **1.71 CARAT**

Color Grade **F**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

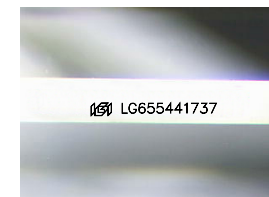
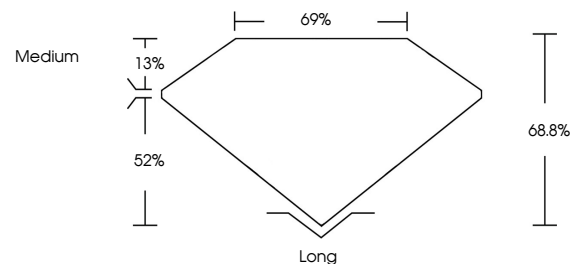
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG655441737**

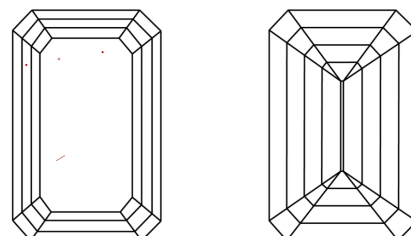
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

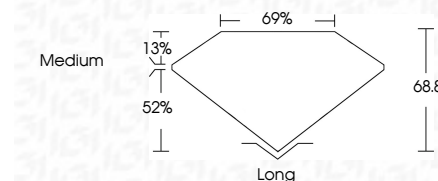
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI

September 30, 2024
IGI Report No. LG655441737
EMERALD CUT
7.87 X 5.57 X 3.83 MM
1.71 CARAT
Color Grade **F**
Clarity Grade **VS 1**
Depth **68.8%**
Table **69%**
Girdle **Medium**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG655441737**

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Type IIa